

Notice of References Cited	Application/Control No. 10/605,319	Applicant(s)/Patent Under Reexamination GRIER ET AL.	
	Examiner Arnel C. Lavarias	Art Unit 2872	Page 1 of 1

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	B	US-6,626,546	09-2003	Grier et al.	359/614
	C	US-6,737,634	05-2004	Curtis et al.	250/222.2
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	E	US-5,939,716	08-1999	Neal, Daniel R.	250/251
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	N	NONE				
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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.